

Notice of References Cited	Application/Control No. 10/669,957	Applicant(s)/Patent Under Reexamination CHEN, JOHN CHU	
	Examiner Raeann Gorden	Art Unit 3711	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-US 20040209705A1	10-2004	Rajagopalan et al	473/354
	B	US-6,762,246 B2	07-2004	Chen, John C.	525/194
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	L	US-			
	M	US-			

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NON-PATENT DOCUMENTS

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